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Invention: **COMPOSITION FOR ANTIREFLECTIVE COATING AND METHOD FOR FORMING SAME**

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I hereby certify that this English Language abstract of JP 08-044066 - 1 Page

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(21)Application number : 06-180168 (71)Applicant : MITSUBISHI CHEM CORP

(22)Date of filing : 01.08.1994 (72)Inventor : NISHI MINEO

MAKISHIMA HIDEO

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(54) SURFACE ANTIREFLECTION COATING COMPOSITION

(57)Abstract:

PURPOSE: To obtain a surface antireflection coating compsn. having a low refractive index, capable of satisfactorily forming and removing a coating film with an aq. medium and suppressing the occurrence of residue by using a water-soluble fluorine compd. contg. a specified compd.

CONSTITUTION: This surface antireflection coating compsn. contains a water-soluble fluorine compd. and water. The fluorine compd. contains one or more kinds of compds. selected from among fluoroalkyl polyether sulfonic acid, its nonmetallic salts, fluoroalkyl polyether carboxylic acid and its nonmetallic salts. The nonmetallic salts mean metal-free salts and include ammonium salts and alkyl substd. ammonium salts such as monoalkyl-, dialkyl- and trialkylammonium salts.

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